

**PATENT APPLICATION**

**RESPONSE UNDER 37 CFR §1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER ART UNIT 1751**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Miho WATANABE et al.

Group Art Unit: 1751

Application No.: 10/765,927

Examiner: J. THOMAS

Filed: January 29, 2004

Docket No.: 118484

For: RESISTANCE ELEMENT, METHOD OF MANUFACTURING THE SAME, AND  
THERMISTOR

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the September 26, 2006, Office Action, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**